

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## ation of:

Murakami et al.

Examiner: Speer, Timothy M. 10/601,576 Serial No.:

Filing Date: June 24, 2003 Art Unit: 1775

Silicon Single Crystal Wafer for Particle Monitor For:

## **AMENDMENT**

Commissioner of Patents PO Box 1450 Alexandria, VA 22303

Sir:

This Amendment is being filed responsive to the Office Action dated May 14, 2007. A petition for a three month extension of time is hereby made and payment is made at the end of this filing. Please amend the application as follows: